



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Zhiping Yin et al. Examiner: Jose Diaz  
Serial No.: 09/259,762 Group Art Unit: 2815  
Filed: March 1, 1999 Docket No: 303.531US1  
Title OXYGEN PLASMA TREATMENT FOR NITRIDE SURFACE TO REDUCE  
PHOTO FOOTING

PETITION FOR A TWO-MONTH EXTENSION OF TIME

MS RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a two-month extension of time be granted in which to respond to the Final Office Action mailed April 7, 2004, said period of response being extended from July 7, 2004 to September 7, 2004.

**Our check in the amount of \$420.00 is enclosed to cover the required extension fee.**  
**Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.**

Respectfully Submitted

ZHIPING YIN ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
P.O. Box 2938  
Minneapolis, MN 55402  
(612) 373-6976

Date: 07 September 04 By: J. M. Kalis  
Jarlal M. Kalis  
Reg. No: 37,650

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelop addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 7 day of September 2004.

Name: Tina Kohut Signature: [Signature]

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